



PATENT APPLICATION  
Docket No. 9898-320  
Client No. SS-16412-US DIV

IN THE  
UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Yun-Hyeok Im and Young-Hoon Ro

Serial No.: 10/646,444 Art Unit: 2811

Filed: August 21, 2003 Examiner: not yet assigned

For: SEMICONDUCTOR PACKAGE HAVING DAM AND METHOD  
FOR FABRICATING THE SAME

Confirmation No. 9520

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement is submitted:

☒ under 37 CFR 1.97 (b); or  
(Within three months of filing national application; or date of entry of International application;  
or before mailing date of first office action on the merits; whichever occurs last)

☒ Applicant(s) submit herewith Form PTO 1449- Information Disclosure Citation together with  
copies of patents, publications or other information of which applicant(s) are aware, which applicant(s) believe(s)  
may be material to the examination of this application and for which there may be a duty to disclose in accordance  
with 37 CFR 1.56.

It is requested that the information disclosed herein be made of record in this application.

Any deficiency or overpayment should be charged or credited to deposit account number 13-1703. A  
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Respectfully submitted,

MARGER JOHNSON & McCOLLOM, P.C.

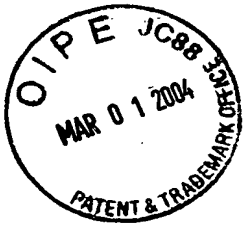
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Date: February 25, 2004

  
Adrienne Chocholak



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INFORMATION DISCLOSURE CITATION  
FORM PTO-1449 (Modified)

FOREIGN PATENT DOCUMENTS

Exam <u>Init</u>	<u>Ref</u>	Document <u>Number</u>	Publication <u>Date</u>	<u>Country</u>	<u>Name</u>
_____	_____	1994-023007	12/1/1998	Korea	
_____	_____	1997-039212	8/18/1997	Korea	

OTHER DOCUMENTS

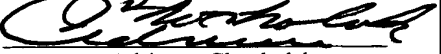
Exam <u>Init</u>	<u>Ref</u>	<u>Author, Title, Date, Pertinent Pages, Etc.)</u>
_____	_____	English language of Korean Patent Publication No. 1994-023007.
_____	_____	English language of Korean Patent Publication No. 1997-039212.

Examiner: \_\_\_\_\_

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